



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

IPW

This application of:

DORDI et al.

Application No: 10/735,216

Filed: December 12, 2003

For: METHOD AND APPARATUS FOR  
MATERIAL DEPOSITION IN  
SEMICONDUCTOR FABRICATION

Docket No: LAM2P458

Group Art Unit: 2813

Examiner: Nguyen, Thanh T.

Date: April 27, 2006

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on April 27, 2006.

Signed:

Kenneth D. Wright

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	29 -	52	00	X25 = \$	OR	X50 = \$
INDEP CLAIMS	04 -	06	00	X100 = \$	OR	X200 = \$

[ ] Multiple Dependent Claim Present  
and Fee Not Previously Paid

\$180

\$360

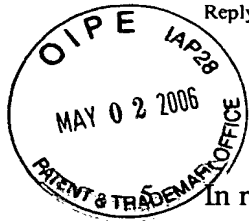
TOTAL

\$ \_\_\_\_\_

\$ \_\_\_\_\_

- ☐ Applicant(s) hereby petition for a \_\_\_\_\_ month(s) extension of time to respond to the outstanding Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM2P458).
- ☐ Enclosed is our Check No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_ to cover the additional claim fee and/or extension of time fees.
- ☒ If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P458). A copy of this sheet is enclosed.

Respectfully submitted,  
MARTINE PENILLA & GENCARELLA, LLPKenneth D. Wright  
Registration No. 53,795710 Lakeway Drive, Suite 200  
Sunnyvale, CA 94085  
Telephone: (408) 774-6903  
Customer Number 25920



**PATENT**

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Signed: \_\_\_\_\_

  
Kenneth D. Wright

**AMENDMENT**

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is submitted in reply to the Office Action dated February 10, 2006, and within the three-month period for reply extending to May 10, 2006. Please enter the following remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this Amendment.

**Remarks/Arguments** begin on page 9 of this Amendment.